

Notice of References Cited

Application/Control No.

09/881,254

Applicant(s)/Patent Under
Reexamination
HSHIEH ET AL.

Examiner

Johannes P Mondt

Art Unit

2826

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-4,116,720	09-1978	Vinson	148/1.5
	B	US-4,250,519	02-1981	Mogi et al.	357/41
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	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Wolf, S., and Tauber, S.N., "Silicon Processing for the VLSI Era", Volume 1 - Process Technology, 2000, Published by Lattice Press, Sunset Beach, CA (USA), Second Edition, p. 206
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.